

Application Data Sheet

Application Information

Application Type::	Regular
Subject Matter::	Utility
Suggested classification::	
Suggested Group Art Unit::	
CD-ROM or CD-R?::	None
Computer Readable Form (CRF)?::	No
Title::	SILICON BUFFERED SHALLOW TRENCH ISOLATION FOR STRAINED SILICON PROCESSES
Attorney Docket Number::	039153-5003 (G0167)
Request for Early Publication?::	No
Request for Non-Publication?::	Yes
Suggested Drawing Figure::	1
Total Drawing Sheets::	4
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	China
Status::	Full Capacity
Given Name::	Qi
Family Name::	Xiang
City of Residence::	San Jose
State or Province of Residence::	CA
Country of Residence::	US
Street of mailing address::	1119 Thames Drive
City of mailing address::	San Jose
State or Province of mailing address::	CA
Postal or Zip Code of mailing address::	95129

Correspondence Information**Correspondence Customer Number::** 34083**E-Mail address::** PTOMailMilwaukee@Foley.com**Representative Information**

Representative Customer Number::	34083	
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Continuation-in-part of	10/341,848	01/15/2003
This Application	Continuation-in-part of	10/341,683	01/15/2003
This Application	Continuation-in-part of	10/358,966	02/05/2003
This Application	Continuation-in-part of	10/389,456	03/14/2003

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::

Assignee Information**Assignee name::** Advanced Micro Devices, Inc.